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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: K. TAKAHASHI, et al.

Serial No: 09/414,520

Filed: October 8, 1999

Title: A PLASMA PROCESSING APPARATUS AND A PLASMA
PROCESSING METHOD

Group: 1763

Examiner: R. ZERVIGON

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 28, 2005

Sir:

In response to the Office Action mailed October 26, 2004, please
amend the above-identified application as listed in the following, and as set
forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.